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MANUS TRANSMITTAL LETTER					Docket No. SON-2611/DIV	
Application No. 10/806,220-Conf. #1765		Filing Date March 23, 2004		Examiner H. Shakeri	Art Ur 3723	
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Docket No.: SON-2611/DIV

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Keiichi Kimura et al.

Application No.: 10/806,220

Filed: March 23, 2004

For: POLISHING METHOD AND POLISHING

APPARATUS

Confirmation No.: 1765

Art Unit: 3723

Examiner: H. Shakeri

SUPPLEMENTAL AMENDMENT IN RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Notice of Non-Compliant Amendment dated March 10, 2005, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.